

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| In re Application of: Yuen et al. | Group Art Unit: 1763 |
| Application No.: 09/718,319 | Examiner: George A. Goudreau |
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| Title: ETCHING A SUBSTRATE IN A PROCESS ZONE | |

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AMENDMENT UNDER 37 C.F.R. 1.111

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Examiner Goudreau:

This communication is in response to the Non-Final Office Action mailed on July 30, 2003, and is being timely filed within three months thereof.

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By Stephen Guzzi
Stephen Guzzi

Date: October 30, 2003